The listing of claims will replace all prior versions, and listings, of claims

in the application:

Listing of Claims:

1 - 39. (Cancelled)

40. (currently amended) A process for treating a fluorine compound-

containing gas, comprising:

contacting a gas stream containing at least one fluorine compound selected

from the group consisting of (a) a compound of carbon and fluorine, (b) a

compound of carbon, hydrogen and fluorine, (c) a compound of carbon, hydrogen,

oxygen and fluorine, (d) SF₆, and (e) NF₃, wherein the concentration of the

fluorine compound is 0.5 to 10% by volume, with a catalyst comprising alumina

as an active compound and 7.2 to 49.4 wt.% of nickel oxide, said catalyst

containing a composite oxide of aluminum and nickel;

adding steam or a reaction gas containing steam and oxygen to the gas

stream; and

effecting a hydrolysis reaction between the at least one flourine compound

and the steam, thereby producing a treated gas containing hydrogen fluoride,

wherein the decomposition activity of the catalyst for fluorine compounds

is maintained at a decomposition rate of 80% to 100% about 80% or greater.

41. (Previously Presented) A process according to Claim 40, further

comprising washing the treated gas with water to remove the hydrogen fluoride.

2. (Previously Presented) A process according to Claim 40, further

comprising washing the treated gas with an alkaline solution or slurry to

neutralize the hydrogen fluoride and other acidic compounds.

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- 43. (Previously Presented) A process according to Claim 40, further comprising washing the treated gas with water and subsequently neutralizing the water that has absorbed the hydrogen fluoride with an alkaline solution or slurry.
- 44. (Previously Presented) A process according to Claim 40, wherein the catalyst further comprises zinc oxide, and wherein a ratio of aluminum to a total of nickel and zinc is 50 to 99: 50 to 1 by atom.
- 45. (Previously Presented) A process according to Claim 40, wherein the catalyst consists essentially of alumina and nickel oxide and a composite oxide of aluminum and nickel.
- 46. (Previously Presented) A process according to Claim 40, wherein the at least one compound is at least one compound selected from the group consisting of CF₄, C₂F₆, C₃F₈, C₄F₈, C₅F₈, CHF₃, CH₂F₂, CH₃F, C₂HF₅, C₂H₂F₄, C₂H₃F₃, C₂H₄F₂, C₂H₅F, CH₂OCF₂, SF₆, and NF₃.
- 47. (Previously Presented) A process according to Claim 40, wherein the at least one compound is at least one compound selected from the group consisting of CF₄, C₂F₆, C₃F₈, C₄F₈, C₅F₈, CHF₃, CH₂F₂, CH₃F, C₂H₅F, C₂H₂F₄, C₂H₃F₃, C₂H₄F₂, C₂H₅F, SF₆, and NF₃.
- 48. (Currently Amended) A method of treating a gas containing a perfluoro-compound, comprising:

contacting the gas containing a fluorine perfluoro-compound in a concentration of 0.5 to 10% by volume at a temperature of 400 to 800°C with a catalyst comprising aluminum oxide as an active component and 7.2 to 49.4 wt.% of nickel oxide, said catalyst containing a composite oxide of aluminum and nickel, in the presence of steam, whereby the perfluoro-compound is decomposed by hydrolysis to produce a treated gas containing hydrogen fluoride and acidic compounds; and

contacting the treated gas with water to absorb the hydrogen fluoride and the acidic compounds from the treated gas.

wherein the decomposition activity of the catalyst for <u>the perfluoro-compound</u> fluorine compounds is maintained at a decomposition rate of <u>80% to 100% about 80% or greater</u>.

- 49. (Previously Presented) A process according to Claim 48, wherein the perfluoro compound is at least one compound selected from the group consisting of CF₄, CHF₃, C₂F₆, C₃F₈, C₄F₈, SF₆ and NF₃.
- 50. (Previously Presented) A process according to Claim 48, wherein the catalyst further comprises zinc oxide, the balance being aluminum oxide.
- 51. (Previously Presented) A process according to Claim 48, wherein the catalyst consists essentially of alumina and nickel oxide and composite oxide of aluminum and nickel.

52 - 74. (Cancelled)

- 75. (Withdrawn) A process according to claim 40, wherein the compound in the gas stream is SF_6 .
- 76. (Withdrawn/Currently Amended) A process according to claim 40, wherein the compound in the gas stream is <u>a compound of</u> carbon, fluorine and hydrogen.
- 77. (Withdrawn) A process according to claim 40, wherein the compound in the gas stream is NF₃.
- 78. (Withdrawn) A process according to claim 40, wherein the compound in the gas stream is at least one member selected from the group consisting of CHF₃, CH₂F₂, CH₃F, C₂HF₅, C₂H₂F₄, C₂H₃F₃, C₂H₄F₂, C₂H₅F, CH₂OCF₂, SF₆ and NF₃.

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- 79. (Previously Presented) A process according to claim 40, wherein the fluorine compound-containing gas to be treated is used as etchants or cleaners for semiconductors.
- 80. (Currently Amended) A process for treating a fluorine compound-containing gas, comprising:

carbon and fluorine, wherein the concentration of the fluorine compound is 2 to 10% by volume, with a catalyst comprising alumina as an active compound and 7.2 to 38.6 wt.% of nickel oxide said catalyst containing a composite oxide of aluminum and nickel;

adding steam or a reaction gas containing steam and oxygen to the gas stream; and

effecting a hydrolysis reaction between the at least one <u>flourine</u> compound and the steam, thereby producing a treated gas containing hydrogen fluoride, wherein a decomposition rate of the at least one compound is maintained at <u>80%</u> to 100% about 80% or greater.

81. (Currently Amended) A process for treating a fluorine compound-containing gas, comprising:

contacting a gas stream containing at least one <u>fluorine</u> compound <u>of</u> consisting of (a) carbon and fluorine at a temperature from about 400 °C to about 800°C, wherein the concentration of the fluorine compound is 0.5 to 10% by volume, with a catalyst comprising alumina as an active compound and 7.2 to 38.6 wt.% of nickel oxide said catalyst containing a composite oxide of aluminum and nickel,

adding steam or a reaction gas containing steam and oxygen to the gas stream; and

effecting a hydrolysis reaction between the at least one compound and the steam, thereby producing a treated gas containing hydrogen fluoride, wherein a decomposition rate of the at least one compound is maintained at 80% to 100% about 80% or greater.

- 82. (Previously Presented) The process of claim 81, wherein said gas stream is contacted with said catalyst at a temperature from about 400 °C to about 700°C.
- 83. (Currently Amended) A process for treating a fluorine compound-containing gas, comprising:

contacting a gas stream containing at least one <u>fluorine</u> compound <u>of</u> consisting of (a) carbon and fluorine at a temperature from about 400 °C to about 700°C, wherein the concentration of the fluorine compound is 0.5 to 10% by volume, with a catalyst comprising alumina as an active compound and about 20 to about 30 wt.% of nickel oxide said catalyst containing a composite oxide of aluminum and nickel,

adding steam or a reaction gas containing steam and oxygen to the gas stream; and

effecting a hydrolysis reaction between the at least one <u>fluorine</u> compound and the steam, thereby producing a treated gas containing hydrogen fluoride, wherein a decomposition rate of the at least one compound is maintained at <u>95%</u> to 100% about 95% or greater.

- 84. (Previously Presented) The process of claim 83, wherein said gas stream is contacted with said catalyst at a temperature from about 400 °C to about 700°C.
- 85. (Previously Added) The process of claim 40, wherein said decomposition activity of the catalyst for fluorine compounds is maintained by the nickel oxide additive.

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86. (Previously Added) The process of claim 48, wherein said decomposition activity of the catalyst for fluorine compounds is maintained by the nickel oxide additive.